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In re Application of:

NEASEMIKA ITO

Application No.: 10/091,461

Filed: March 7, 2002

For: SOI SUBSTRATE, ANNEALING
METHOD THEREFOR, SEMICONDUCTOR
DEVICE HAVING THE SOI SUBSTRATE,
AND METHOD OF MANUFACTURING
THE SAME

Docket No. 00862.022541.

Examiner: S. Isaac

Group Art Unit: 2812

2812
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Date: August 22, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

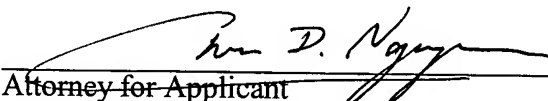
CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	16	MINUS	20	= 0	x \$9 \$18	.00
INDEP. CLAIMS	2	MINUS	3	= 0	x \$42 \$84	.00
Fee for Multiple Dependent claims \$140°/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						.00

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

☐ A check in the amount of \$_____ is enclosed.

- ☐ Charge \$____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☐ A check in the amount of \$____ to cover the fee for a ____ month extension is enclosed.
- ☐ A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

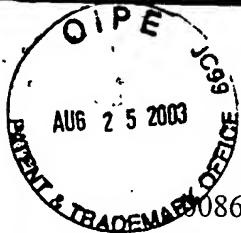


Attorney for Applicant

Registration No. 54,336

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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0862.022541.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TECHNOLOGY CENTER 2800

In re Application of:)
MASATAKA ITO)
Application No.: 10/091,461)
Filed: March 7, 2002)
For: SOI SUBSTRATE, ANNEALING)
METHOD THEREFOR,)
SEMICONDUCTOR DEVICE)
HAVING THE SOI SUBSTRATE,)
AND METHOD OF)
MANUFACTURING THE SAME :
Examiner: S. Isaac
Group Art Unit: 2812
August 22, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

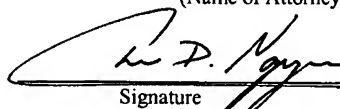
Sir:

In response to the Office Action dated May 22, 2003 (Paper No. 9), please
amend the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450 on

August 22, 2003
(Date of Deposit)

Chris D. Nguyen (Reg. No. 54,336)
(Name of Attorney for Applicant)


Signature
August 22, 2003
Date of Signature